Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/664,931	CHAE ET AL.
	Examiner	Art Unit
	Richard H. Kim	2871

SEARCHED

Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

SEARCH NOTES
(INCLUDING SEARCH STRATEGY)

	DATE	EXMR
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